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PETITION FOR EXTENSION OF TIME UNDER 37 CFR 1.136(a)
(Large Entity)

Docket No.
86397

In Re Application Of: **Satoshi Komiya et al.**

Serial No.
10/049,875

Filing Date
February 10, 2002

Examiner
Robert M. Kunemund

Group Art Unit
1765

Invention: **SILICON WAFER AND METHOD FOR MANUFACTURE THEREOF, AND METHOD OF
EVALUATION OF SILICON WAFER**

TO THE COMMISSIONER FOR PATENTS:

This is a request under the provisions of 37 CFR 1.136(a) to extend the period for filing a response to the Office Action of 06/03/2003 above-identified application.
Date

The requested extension is as follows (check time period desired):

☐ One month ☐ Two months ☒ Three months ☐ Four months ☐ Five months

from: 09/03/2003
Date

until: 12/03/2003
Date

The fee for the extension of time is **\$950** and is to be paid as follows:

- ☒ A check in the amount of the fee is enclosed.
☒ The Director is hereby authorized to charge any fees which may be required, or credit any overpayment, to Deposit Account No. **23-0920**
☒ If an additional extension of time is required, please consider this a petition therefor and charge any additional fees which may be required to Deposit Account No. **23-0920**

Gerald T. Shekleton
Signature

Dated:

Gerald T. Shekleton
Welsh & Katz, Ltd.
120 South Riverside Plaza
22nd Floor
Chicago, Illinois 60606
312/655-1500

I certify that this document and fee is being deposited on 11/26/03 with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Gerald T. Shekleton

Signature of Person Mailing Correspondence

Gerald T. Shekleton

Typed or Printed Name of Person Mailing Correspondence

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